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|--|----|---|------------|--------------------------------------|-------------------------|-----------|-------------|
| <b>FORM PTO-1449</b><br><b>INFORMATION DISCLOSURE STATEMENT</b>  |    |   |            | Attorney ref.:                       | Application serial No.: |           |             |
|  |    |   |            | AI 412NP                             | 10/577,361              |           |             |
|  |    |   |            | Applicant(s):<br><br>Masaru TAKAISHI |                         |           |             |
|  |    |   |            | Filing date:                         | Group art unit:         |           |             |
|  |    |   |            | April 28, 2006                       | 2895                    |           |             |
| <b>FOREIGN PATENT DOCUMENTS</b>  |    |   |            |                                      |                         |           |             |
| Examiner Initial   |    | Document Number   | Date       | Country                              | Class                   | Sub-Class | Translation |
|  | AA | 63-58960  | 03-14-1988 | JAPAN                                |                         |           | Abstract    |
|  | AB | EP 1 168 455 A2   | 01-02-2002 | EUROPE                               |                         |           | N/a         |
| <b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>  |    |   |            |                                      |                         |           |             |
|  | AC | SAGGIO M ET AL: "MDMESH <sup>TM</sup> : INNOVATIVE TECHNOLOGY FOR HIGH VOLTAGE POWERMOSFETS" PROCEEDINGS OF THE INTERNATIONAL SYMPOSIUM ON POWERSEMICONDUCTOR DEVICES AND ICS, NEW YORK, NY, US, 22 May 2000 (2000-05-22), pages 65-68, XP000985371 |            |                                      |                         |           |             |
| Examiner:  |    |   |            |                                      | Date Considered:        |           |             |
| EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant. |    |   |            |                                      |                         |           |             |